

Docket No.: YHK-039

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Ho Young CHOI et al. / :  
Serial No. 09/514,250 / : Group Art Unit: 2872  
Filed: February 28, 2000 / : Examiner: A. Chang  
For: PROJECTION LENS SYSTEM :  
  
#14  
Ext. 1 mo.  
J. Mueller  
2/8/02

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(1)**

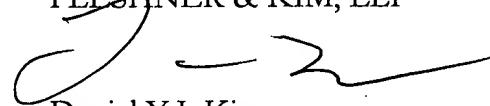
Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

Applicant petitions the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated October 12, 2001 for one (1) month from **January 12, 2002** to **February 12, 2002**.

A check including the amount for the extension of time under 37 C.F.R. §1.17(a) is enclosed. Any deficiency or overpayment should be charged or credited to Deposit Account No. 16-0607.

Respectfully submitted,  
FLESHNER & KIM, LLP

  
Daniel Y.J. Kim  
Registration No. 36,186  
Laura L. Lee  
Registration No. 48,752

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P.O. Box 221200  
Chantilly, VA 20153-1200  
(703) 502-9440 DYK/LLL:lms  
**Date: February 4, 2002**